

Application No. 09/908,292  
Declaration Submitted Pursuant to 37 C.F.R. §1.131  
Supplemental to Reply to Office Action of May 28, 2003

Agilent Dkt No. 10010218-1  
R&E Dkt No. 5000-0059

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### APPENDIX (REDACTED INVENTION DISCLOSURE)



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## INVENTION DISCLOSURE

PAGE ONE OF

NO 10010218 DATE RCVD

ATTORNEY MJB

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Descriptive Title of Invention:

Micro-fluidic flow switching device

Name of Project:

Micro Analytical Technologies

Product Name or Number: n/a

Has the invention been published, or are you planning to publish? If so, the date(s) and publication(s):

0

Has the invention been announced, offered for sale, sold, or is such activity proposed? If so, the date(s) and location(s):

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Has the invention been disclosed to anyone outside of AGILENT TECHNOLOGIES, or will such disclosure occur? If so, the date(s) and name(s):

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If any of the above situations will occur within 3 months, call your IP attorney or the Legal Department now at 1-553-3061 or 408-553-3061.

Has the invention been described in a lab book or other record? If so, please identify (lab book #, etc.)

088-46,47,48,49,53,54,55

Has the invention been built or tested? If so, the date:

es, [redacted]

Has this invention been made under a government contract? If so, the agency and contract number:

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Description of Invention: Please preserve all records of the invention and attach additional pages for the following. Each additional page should be signed and dated by the inventor(s) and witness(es).

- A. Prior solutions and their disadvantages (if available, attach copies of product literature, technical articles, patents, etc.).
- B. Problems solved by the invention.
- C. Advantages of the invention over what has been done before.
- D. Description of the construction and operation of the invention (include appropriate schematic, block, & timing diagrams; drawings; samples; graphs; flowcharts; computer listings; test results; etc.)

Signature of Inventor(s): I (we) hereby submit this disclosure on this date: [redacted].

Employee No.	Name	Signature	Telex	Mailstop	Entity & Lab Name
	Kevin Kileon	[Signature]			
Employee No.	Name	Signature	Telex	Mailstop	Entity & Lab Name
	Hongfang Yin	[Signature]			
Employee No.	Name	Signature	Telex	Mailstop	Entity & Lab Name

(If more than four inventors, include additional information on another copy of this form and attach to this document)

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nature of Witness(es): (Please try to obtain the signature of the person(s) to whom invention was first disclosed.)							
Invention was first explained to, and understood by, me (us) on this date: [REDACTED]							
Name		Signature		Date of Signature		[REDACTED]	
Tom A. Van de Goot		[Signature]		[REDACTED]		[REDACTED]	
Name		Signature		Date of Signature		[REDACTED]	
harmila R. Udiavar		[Signature]		[REDACTED]		[REDACTED]	
Inventor & Home Address Information: (If more than four inventors, include addl. information on a copy of this form & attach to this document)							
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**Invention Disclosure**  
**Micro-fluidic flow switching devices**

Kevin Killeen and Hongfeng Yin, Agilent Labs, [REDACTED]

**Background**

Micro-fluidic ( $\mu$ -fluidic) devices hold great promises for many applications. One of the most critical  $\mu$ -fluidic elements is a low dead volume, reliable and leak free flow switching element (valve). Applications such as sample introduction, step gradient and linear gradient liquid chromatography (LC), the introduction of reagents into a flow stream, and the selection from different flow streams and/or fraction collection into different fluidic chambers etc. all require a valve to be successfully practiced.

**Prior Art**

Valve structures generated by silicon micro-machining technologies are described in US Patent Nos.: 4,768,751; 5,725,017; 5,964,239; 5,927,325; 6,102,068; 5,771,902; 5,333,831; 5,368,704; 5,417,235; 5,819,749; and 4,869,282. Laser ablated butt-coupled rotor-stator valve design has been described in US patent Nos.: 5,500,071; 5,568,413, and 5,571,410.

**Summary of the invention**

The present invention relates to a micro machined flow-switching device for use in micro fluidic applications. In the preferred embodiment of the present invention, two micro fluidic substrates form a high pressure capable, face seal rotary valve where fluidic structures on both devices are in fluidic communications with each other. Flow path switching is achieved with actuation and rotation of one substrate relative to the other with the capability to connect multiple flow channels sequentially or simultaneously. In another embodiment, one of the substrate is simply a rotor seal or binary shut off valve. In another embodiment, at least one of the substrates can be connected to external fluid source. An alternative embodiment would be a relative displacement (linear or combination motion e.g. slide valve), rather than just rotary motion between elements. This valve concept is extensible to multiple micro fluidic valve elements sandwiched between layers of micro fluidic structured channels.

The actuation of the valve is via mechanical coupling to a motor or pneumatically driven shaft. Alternatively, by choice of proper materials, the valve material itself may be driven by magnetic or electrical forces for non-contact actuation.

The materials of construction used in the present embodiment are low cost polymers, specifically commercial grade polyimide (Kapton™) and PEEK (polyetherether ketone). These materials can be processed by tool machining, laser ablation and plasma etching to form  $\mu$ -fluidic structures in surfaces. PEEK can also be embossed or injection molded to define fluidic features. Elements constructed from alternative polymer and/or solid materials combinations are possible if they are chemically compatible with the fluids in contact with them, can withstand the internal pressures of the application without fatigue or leaks, and are mechanically stable to wear during repetitive actuation of the valve. A reliable seal between the moving elements is enhanced by using (a) compliant material(s) with the deformation of one element relative to the other forming a leak tight structure statically and during actuation.

A commercial ten-port valve design has been used to test operation in both the flow injection analysis (FIA) mode and step gradient LC mode. In step gradient mode, one loop is loaded with sample and the other loop is loaded with high percentage organic mobile phase. By switching between the two positions, sample is first loaded during the time that the LC column is flushed with mobile phase A. Then, the valve is switched. Now, sample is injected onto the LC column and non-retaining compounds are eluted by mobile phase A while Loop B is loaded with mobile phase B. Then the valve is switched again, and mobile phase B in loop B is pushed through LC column and sample is eluted through ES spray tip into Mass Spectrometer.

**Functions that can be addressed by the face seal rotary valve design:**

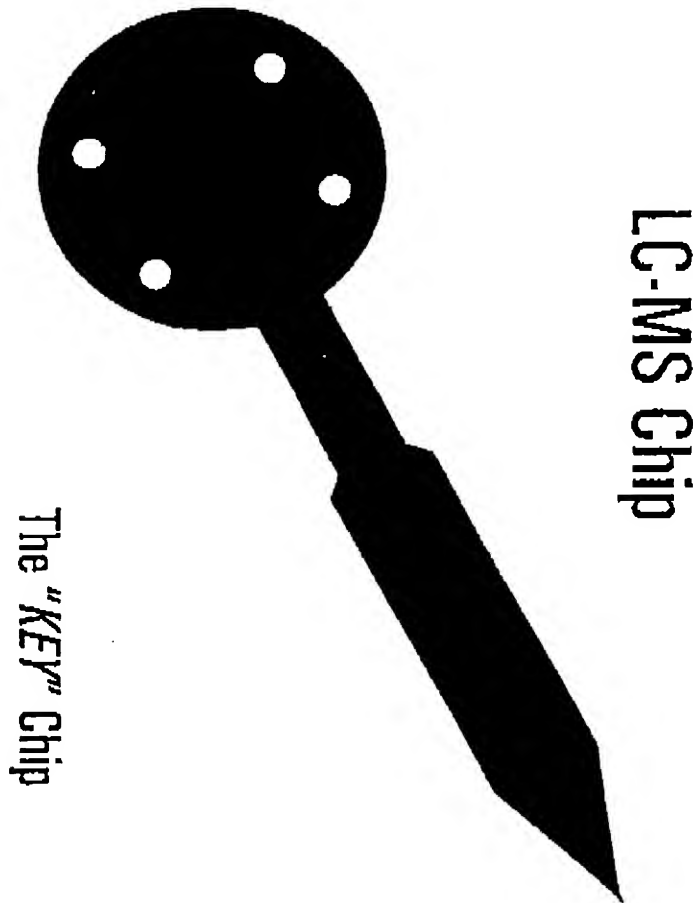
1. High pressure (>250 bar), low dead volume, leak free, simultaneous or sequential connection of multiple flow paths.
2. Fixed loop microinjection of sample for FIA mass spec analysis (commonly practiced with a 6-port design)
2. Fix loop injection for step gradient LC separation (10-port design as described above)

3. Fix loop sample injection for true gradient LC (6-port design, also with switching of splitting point)
4. Multi-position selection valve for sample selection, fraction collection and flow diversion
5. Multiple-switching with single actuation, rotor seal can address multi-channel simultaneously or actuator can address multi-rotor seals simultaneously.
6. Shut-off valve to allow or stop flow between fluid paths connected via the rotary seal.
7. Sequential switching design between differing flow paths to generate a LC gradient on chip.
8. Multilayer, stacked valve elements sandwiched between u-fluidic layered structures.



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LC-MS Chip

The "KEY" Chip

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# Essential Elements of the Key Prototype



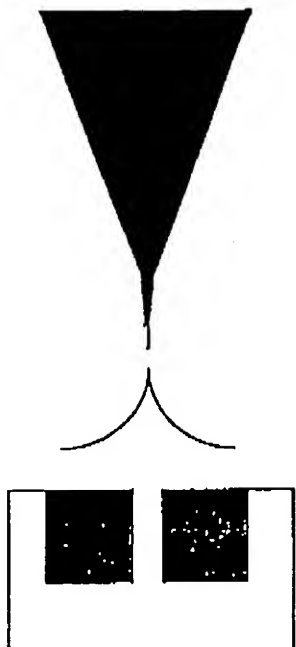
*pump*



*valve*



*column*



*detector*  
*(ESI-MS)*



*HP, LDV connections*



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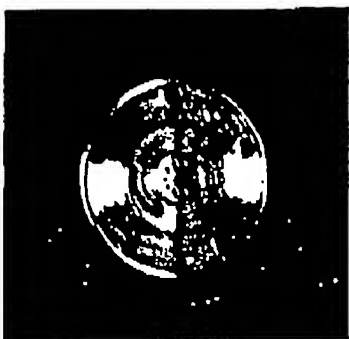


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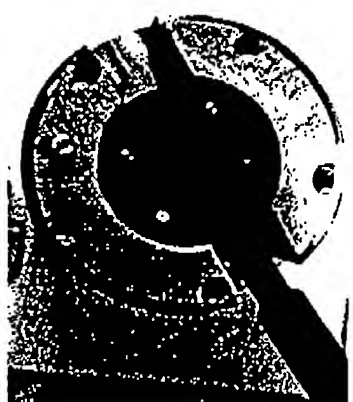
# Valve to Chip Interface



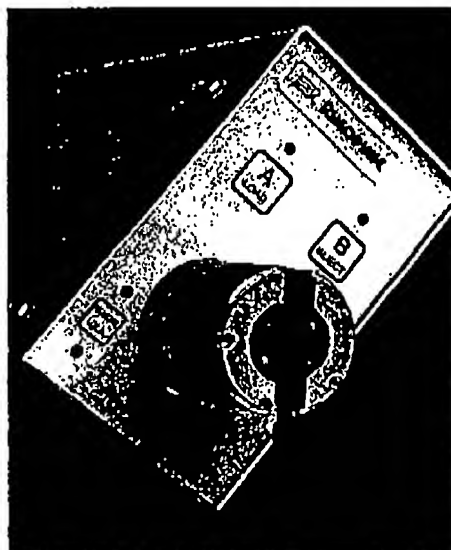
1 nl, laser ablated  
PEEK rotor loops



Inside face of 10  
port SS stator



Kapton Key chip  
face sealed between  
rotor and stator.  
Tested to 250 Bar.



Flow switching using 2  
position actuator

Switching by valve motion  
Mechanical actuation vs.  
electrical switching for CE or CEC



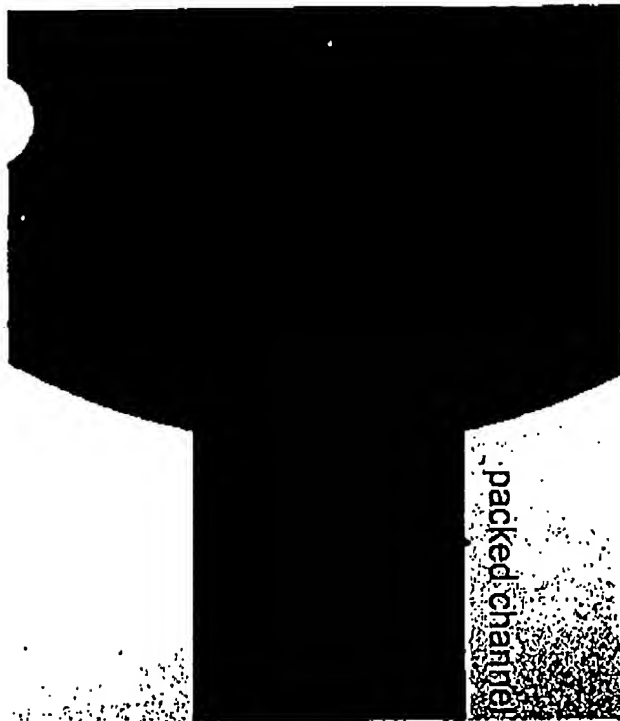
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## LC Column Packing

Industry-standard Packing / LC Chemistry:

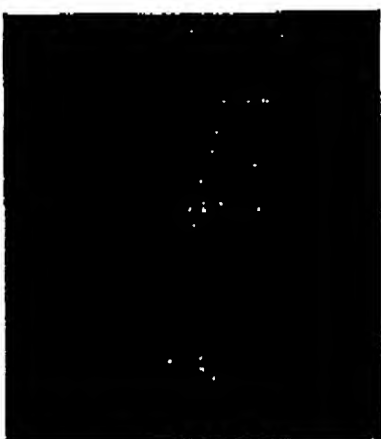
*Proven LC technologies and methodologies*



Reflection image



5  $\mu$ m bead diameter

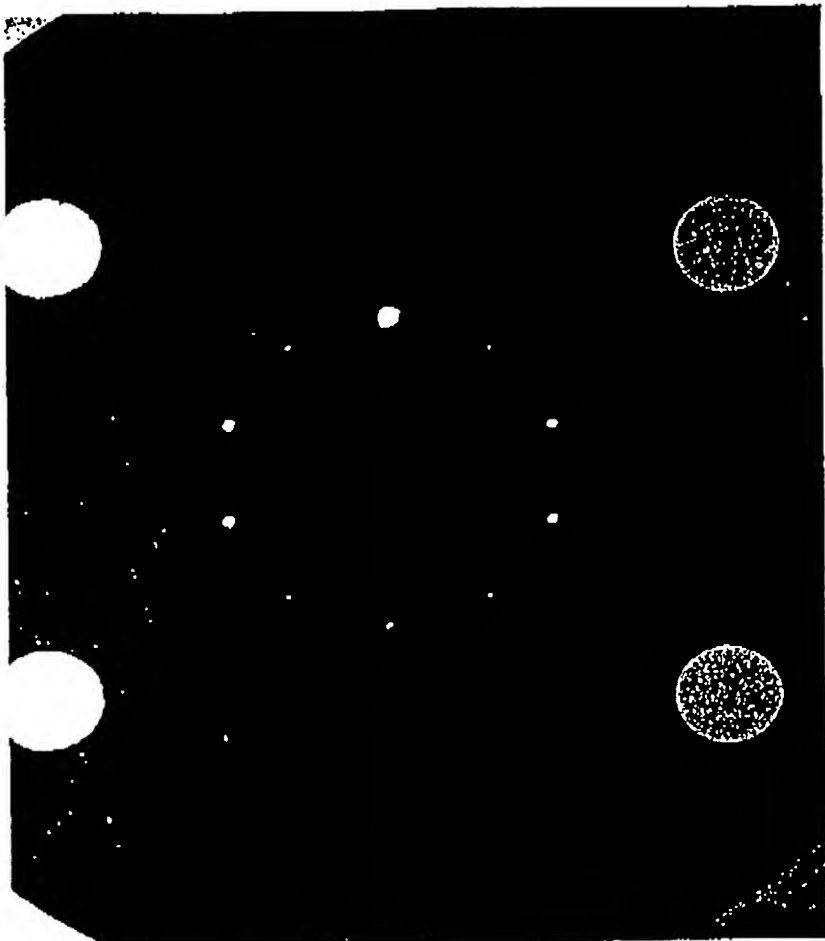


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## KEY Chip Layout



Sample loop = 11.2 nl  
Loop B = 26.6 nl  
Column Volume before  
packing = 27.3 nl

**Integrated on-chip sample  
loop, mobile phase B loop,  
LC column, and flow  
switching means**

***Low dead and delay volume,  
fast separation and washout,  
low carry-over***

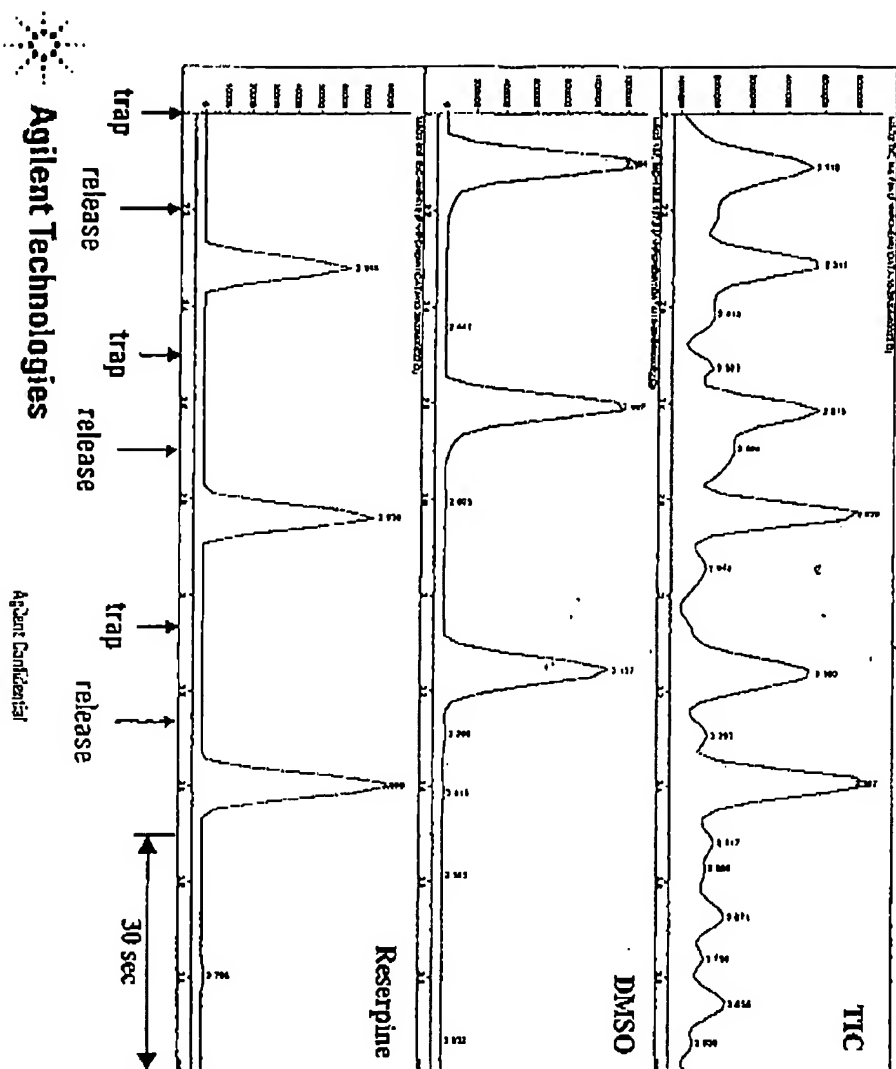


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## Fast Clean-up

Remove DMSO interference from Reserpine

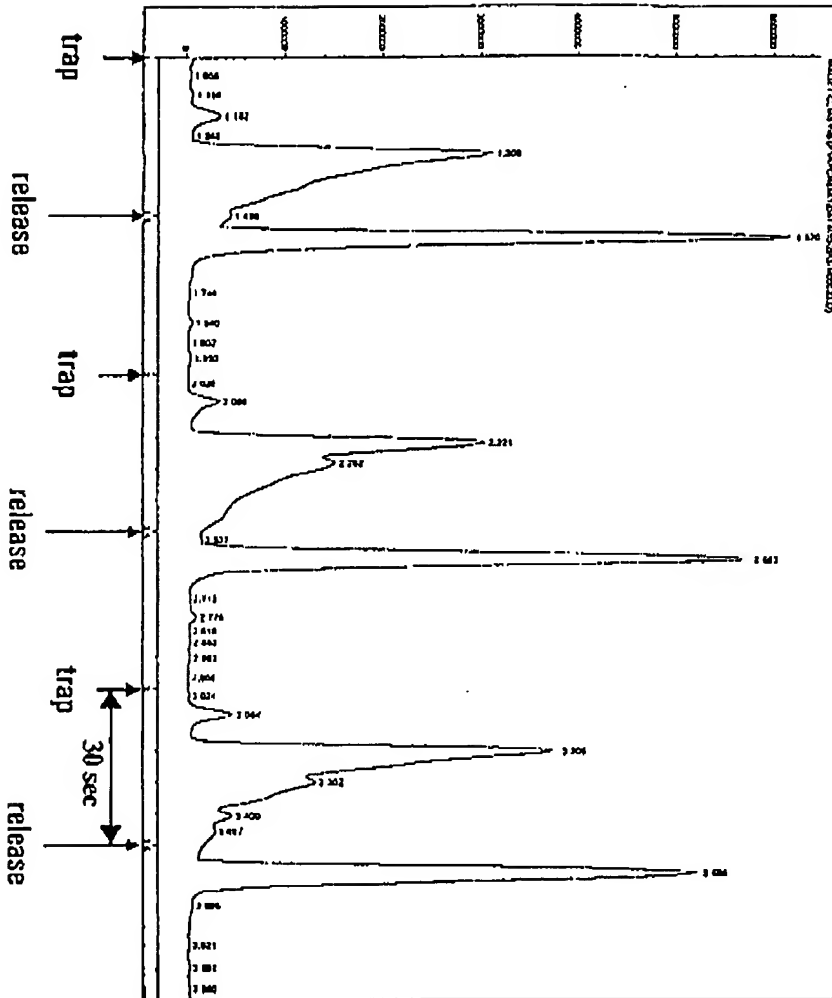


**Experiment condition:**  
**MS:** Sprite single Q MS, scan  
 70 – 650 amu  
**Sample:** 1ug/ml reserpine in 0.1%  
 DMSO, 10 pg injected  
**Mobile phase A:**  
 10% Methanol/Water, 0.5% formic  
 acid  
**Mobile Phase B:**  
 90% Methanol/Water, 0.5% formic  
 acid  
**Flow rate:** 1ul/min  
**Injection:** 10nl loop  
**B loop:** 25nl  
**Step Gradient:**  
 0 min- inject sample, load loop B  
 0.2 min flush column with B, new  
 sample loaded  
 0.5 min inject new sample



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## Step Gradient LC-MS Clean-up and separation of peptide mixture

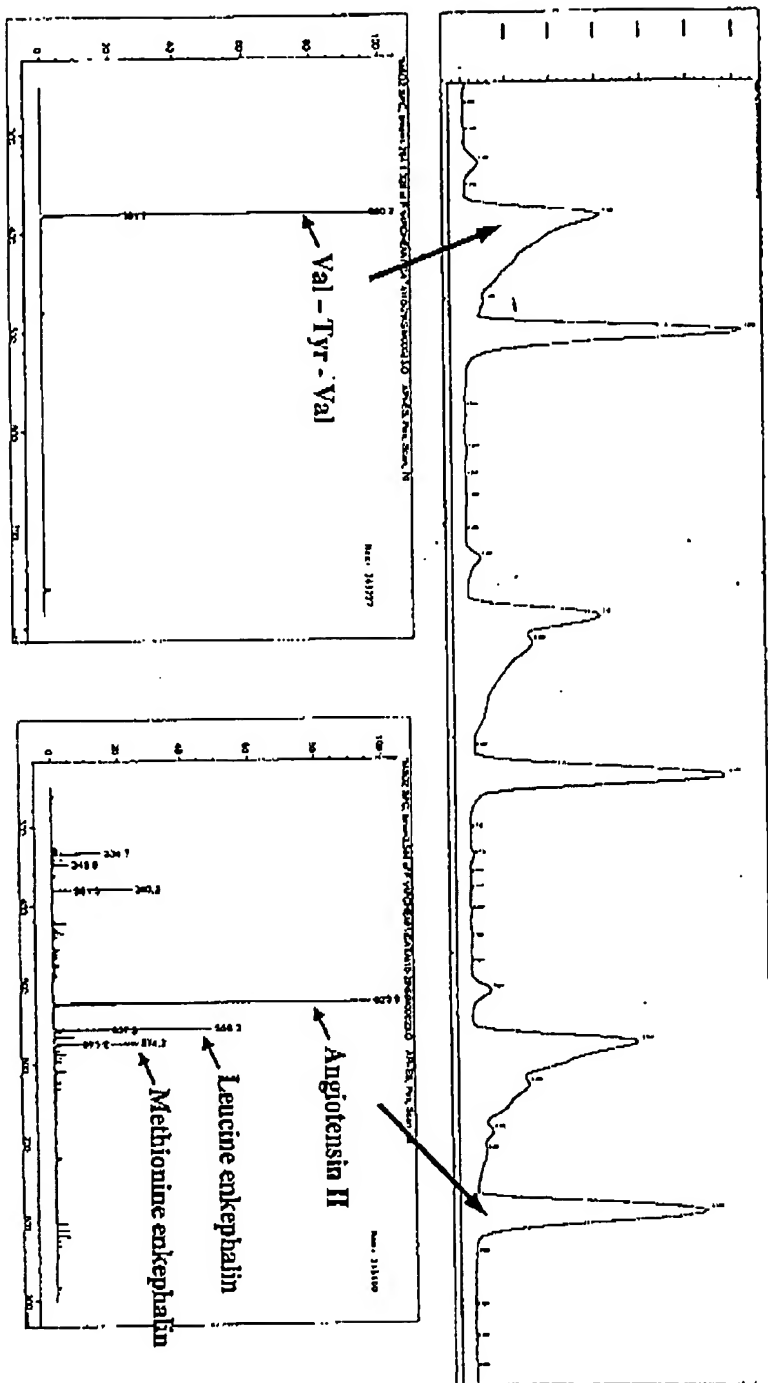
**Experiment condition:**  
**MS:** Sprite single Q, scan 250-900 amu  
**Sample:** Sigma LC peptide mix  
**Mobile phase A:** 10% Methanol/Water, 0.5% formic acid  
**Mobile Phase B:** 90% Methanol/Water, 0.5% formic acid  
**Flow rate:** 1ul/min  
**Injection:** 10nl loop  
**B loop:** 25nl  
**Step Gradient:**  
 0 min, inject sample, load loop B  
 0.5 min flush column with B, new sample loaded  
 1.0 min inject new sample



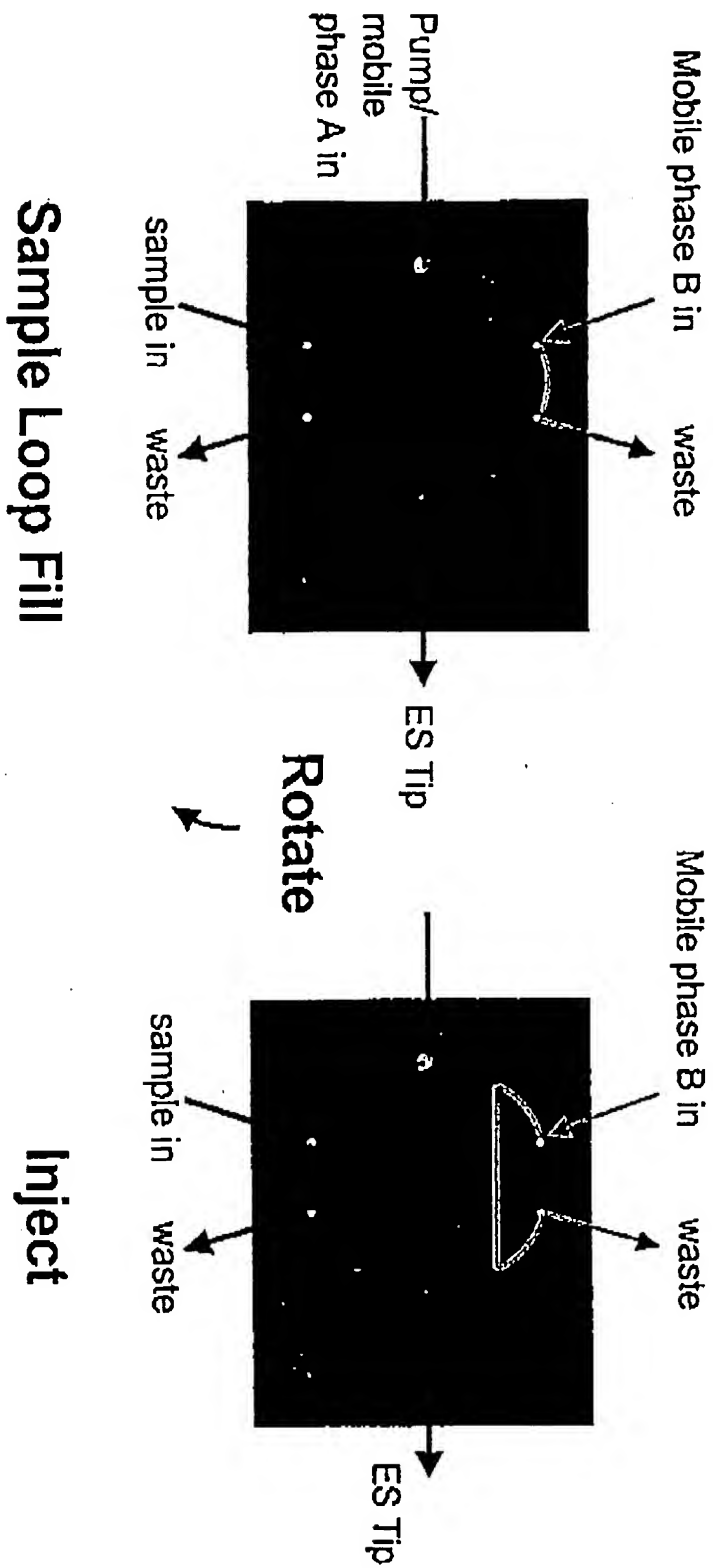
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## Step Gradient LC-MS Clean-up and separation of peptide mixture



# Flow Switching and Sample Injection for Step Gradient LC



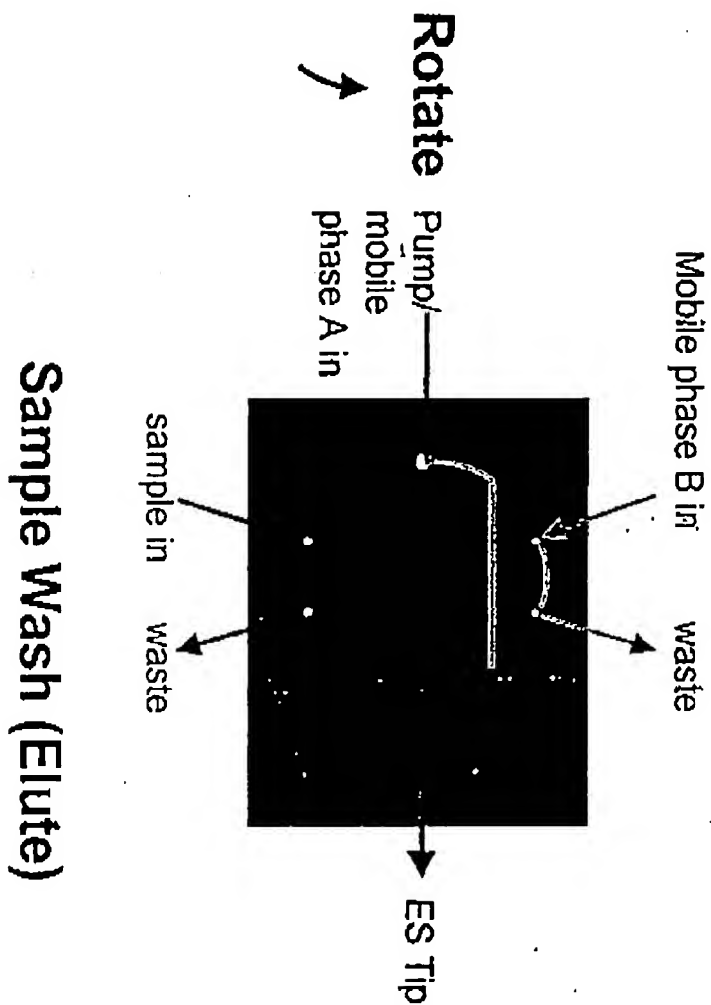
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# Flow Switching and Wash for Step Gradient LC

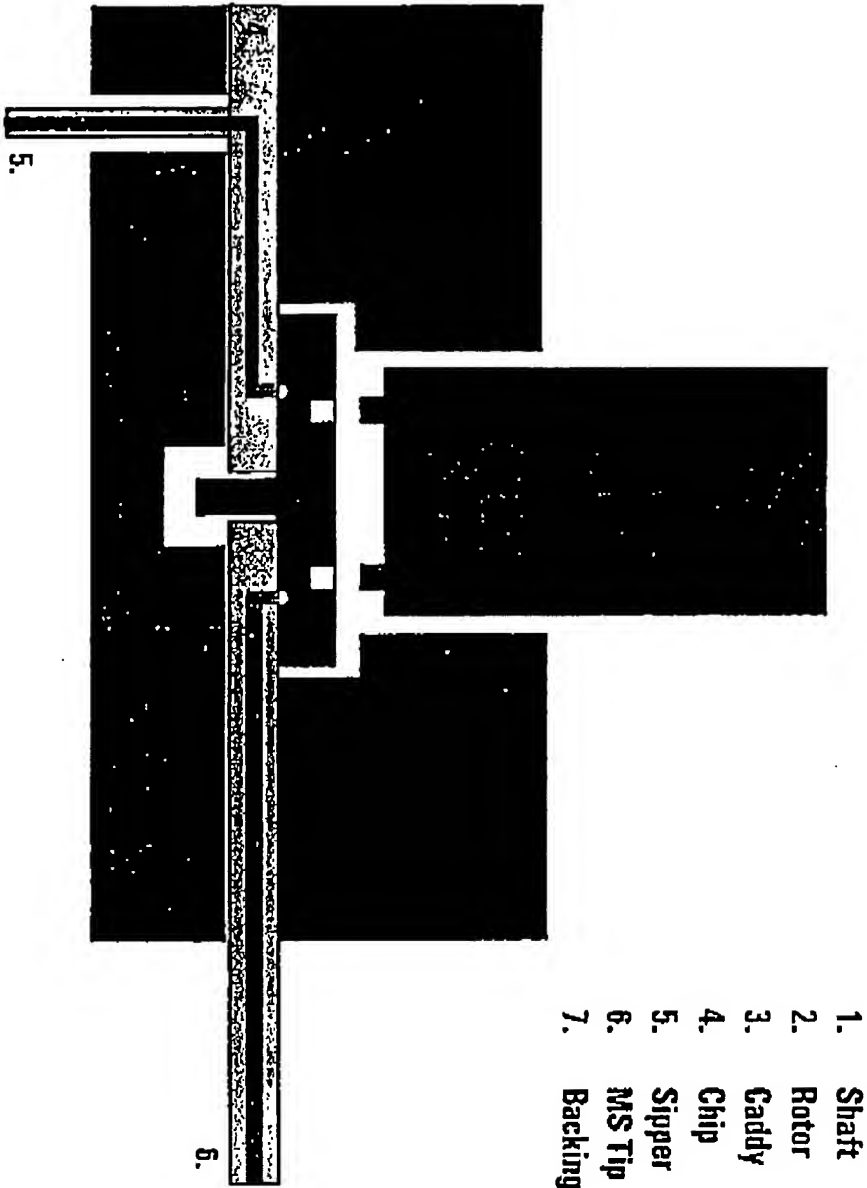


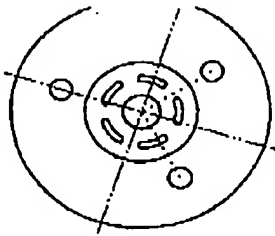
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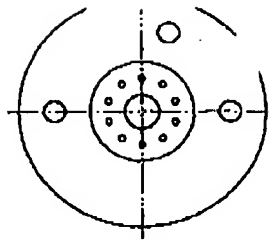


## LC-MS Concept



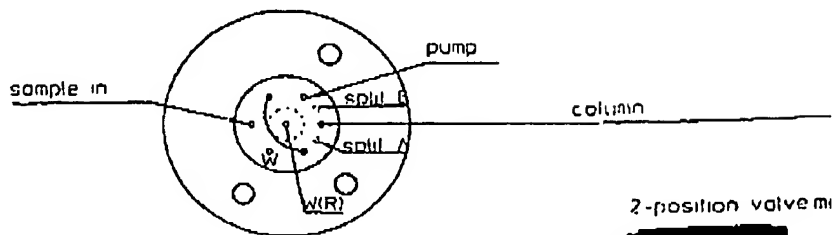
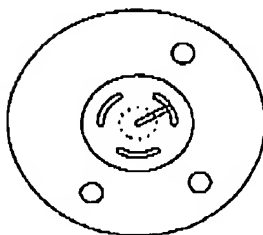
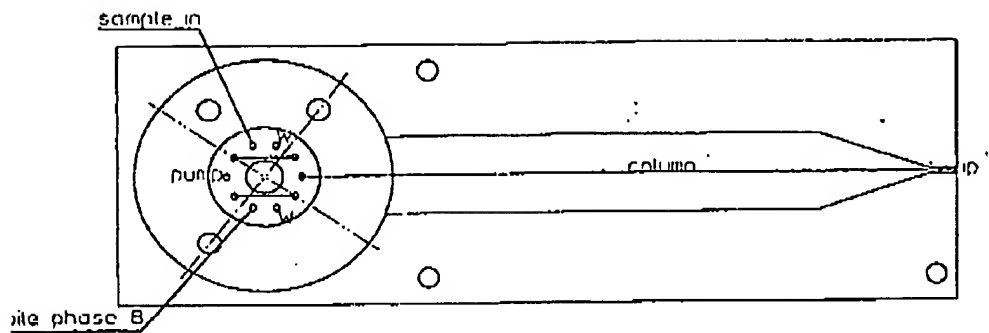


Rheodyne rotor seal



Rheodyne stator face assembly

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2-position valve m  
Hongfeng Yin

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